SYSTEM AND METHOD FOR ONE-TIME PROGRAMMED MEMORY THROUGH DIRECT-TUNNELING OXIDE BREAKDOWN

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Cross-Reference to Related Applications

[0001] This application is a continuation of U.S. Patent Application No. 09/739,752, filed December 20, 2000, entitled, "System and Method for One-Time Programmed Memory Through Direct-Tunneling Oxide Breakdown."

Background of the Invention

Field of the Invention

[0002] The present invention relates to integrated circuits, and more specifically to a CMOS non-volatile memory circuit.

Background Art

louding In the field of data storage, there are two main types of storage elements. The first type is volatile memory that has the information stored in a particular storage element and the information is lost the instant the power is removed from the circuit. The second type is a non-volatile storage element in which the information is preserved even with the power removed. Of the second type, some designs allow multiple programming while other designs allow one-time programming. Typically, the manufacturing techniques used to form non-volatile memory are quite different from a standard logic processes, thereby dramatically increasing the complexity and chip size.

the integration of both NMOS and PMOS transistors on a silicon substrate. The NMOS transistor consists of a N-type doped polysilicon gate, a channel conduction region, and source/drain regions formed by diffusion of N-type dopant in the silicon substrate. The channel region separates the source from the drain in the lateral direction, whereas a layer of dielectric material that prevents electrical current flow separates the polysilicon gate from the channel. Similarly, the architecture is the same for the PMOS transistor but a P-type dopant is used.

[0005] The dielectric material separating the polysilicon gate from the channel region, henceforth referred to as the gate oxide, usually consists of the thermally grown silicon dioxide (SiO₂) material that leaks very little current through a mechanism called Fowler-Nordheim tunneling under voltage stress. When stressed beyond a critical electrical field (applied voltage divided by the thickness of the oxide), the transistor is destroyed by rupturing of the oxide.

[0006] Thin oxides that allow direct tunneling current behave quite differently than thicker oxides, which exhibit Fowler-Nordheim tunneling. Rupturing thin oxide requires consideration for pulse width duration and amplitude to limit power through the gate oxide to produce reliable, low resistance antifuse.

Rupturing the gate oxide is a technique used to program a non-volatile memory array. U.S. Patent no. 6,044,012 discloses a technique for rupturing the gate oxide, but the oxide is about 40Å to 70Å thick. The probability of direct tunneling, rather than Fowler-Nordheim tunneling, of gate current through an oxide of this thickness is extremely low. Also, the voltage required to rupture the oxide is substantially higher and requires a charge pump circuit. The '012 patent does not disclose final programmed resistance, but such is believed to be in the high kilo (K) ohms range.

[0008] U.S. Patent no. 5,886,392 discloses a one-time programmable element having a controlled programmed state resistance with multiple anti-fuses. Both the final resistance values are high in the K-ohms range and the spread of these values is wide as well. Again, a complicated circuit would have to be designed if the final resistance is not within a tight range. Adding more anti-fuses can lower the resistance but increases the die size.

[0009] What is needed is a one-time programmable CMOS circuit and method that is compatible with non-volatile memory array architecture for sub 0.13μm process technology.

Brief Summary of the Invention

- [0010] The present invention provides a one-time programmable non-volatile memory structure that is fabricated using standard 0.13μm CMOS process technology. The invention uses a core CMOS anti-fuse transistor having a source region and a drain region that are commonly tied together in a capacitor configuration. The anti-fuse transistor is programmed by applying a high programming voltage to its gate, thereby rupturing the gate oxide of the transistor. The oxide is about 20Å thick, which allows direct tunneling current and yields an after-programmed resistance on the order of a few hundred ohms or less, which is an order of magnitude lower then conventional one-time programmable anti-fuses. Voltage to rupture gate oxide can be adjusted depending on the programming time pulse and final resistance spread requirement.
- [0011] In one embodiment, the anti-fuse transistor is enclosed in a deep N-well structure, which allows the surrounding deep N-well to be biased at a different voltage to isolate the memory cell. In this embodiment, the gate can be programmed at a lower voltage than without a deep N-well enclosure.
- [0012] In another embodiment, the state of the anti-fuse transistor is programmed through a 5-volt tolerant circuitry and read through a 1.2-volt sensing circuit.
- [0013] In yet another embodiment, the anti-fuse transistor can be used as a fixed low-resistance resistor, connected in series or in parallel to achieve the desired resistance.
- [0014] These and other objects, advantages and features will become readily apparent in view of the following detailed description of the invention.

Brief Description of the Drawings/Figures

[0015] The features and advantages of the present invention will become more apparent from the detailed description set forth below when taken in SKGF Ref: 1875.0220001

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conjunction with the drawings in which like reference numbers indicate identical or functionally similar elements. Additionally, the left-most digit of a reference number identifies the drawing in which the reference number first appears.

- [0016] FIG. 1 illustrates a block diagram of a one-time programmable storage cell and ancillary circuitry, according to the present invention.
- [0017] FIG. 2 illustrates a schematic diagram corresponding to FIG. 1.
- [0018] FIG. 3 illustrates a deep N-well MOSFET used to implement the main element of the storage cell, according to an embodiment of the present invention.
- [0019] FIG. 4 illustrates another embodiment using 5-volt tolerant switches.
- [0020] FIGs. 5A and 5B are graphs showing data corresponding to the breakdown characteristics of the gate oxide, according to the present invention.
- [0021] FIGs. 6A and 6B show example data resulting from programming the anti-fuse transistors, according to the present invention.
- [0022] Finally, FIG. 7 illustrates a plot of the final (after programming) antifuse resistance versus applied power, according to the present invention.

Detailed Description of the Invention

- [0023] The term anti-fuse and the terms storage or programmable coupled with the terms cell, element, or device are often used interchangeably in this field. The present invention is applicable to all the above as they are generally understood in the field.
- [0024] According to the present invention, the physical current used to rupture (also referred to as "breakdown") an oxide is dominated by a different mechanism than in prior art anti-fuses fabricated according to 0.35µm and 0.18µm process technologies. In the present invention, the oxide rupture can be more controlled and the final programmed resistance is much lower than conventional devices. A smaller variance on programmed resistance allows a more compact circuit design to determine the state of the memory cell. Moreover, the lower voltage required to rupture the anti-fuse oxide means no

charge pump circuitry is required, thus making a simpler memory array design and smaller circuit area requirement.

[0025] Controlling the programmed state resistance is a disadvantage of conventional anti-fuses. For example, one conventional programmed anti-fuse may have a resistance of a few kilo ohms, while a neighboring anti-fuse on the same IC may have a resistance in the range of 10 to 100 kilo ohms. The present invention avoids this problem. The programmed state resistance varies minimally between anti-fuses made according to the present invention.

[0026] Another disadvantage of the conventional anti-fuses is the instability of their programmed state resistance. Specifically, the resistance of the programmed anti-fuses tends to increase over time. In the worst case, the programmed anti-fuse may actually switch from the programmed state to the unprogrammed state resulting in circuit failure. The programmed state resistance of anti-fuses made according to the present invention is more stable over time compared to conventional anti-fuses.

[0027] FIG. 1 illustrates a block diagram of a one-time programmable storage cell and ancillary circuitry, according to the present invention. The block diagram of FIG. 1 includes a storage cell 102, and a write circuit 104, a read circuit 106 and a current bias and voltage clamp circuit 108.

FIG. 2 illustrates an example schematic diagram of an embodiment corresponding to FIG. 1. The storage cell 102 comprises a resistive load (Rload) 202, a diode 204, a write switch 206, and two read switches 208 and 210. Rload 202 is an ideal representation of an anti-fuse, comprising a capacitor or MOS transistor configured as a capacitor. In the latter instance, the source and drain of the transistor are coupled together to form one plate of the capacitor. The other plate is formed by the transistor gate, and the plates are separated by a gate oxide. The gate oxide layer is approximately 20Å thick, which can be achieved with 0.13μm or less process technology. This thickness is chosen so that the gate can be ruptured by direct tunneling gate current, rather than Fowler-Nordheim tunneling.

[0029] The diode 204, write switch 206 and read switches 208 and 210 can be implemented using transistors or the like, as would become apparent to a person skilled in the relevant art. The operation of these elements will be described below.

[0030] Write circuit 104 comprises a read switch 212 and a write switch 214 coupled in series between zero (i.e., ground) and negative 3.5-volt supplies. Current bias and voltage clamp circuit 108 comprises a current source 216 and a 1.2-volt clamp circuit 218 to provide a 2.5-volt supply to a node labeled "vload" of the storage cell 102. The current source 216 and a 1.2-volt clamp circuit 218 are coupled to a node, which in turn is coupled to read switch 208 via a connection labeled "ifeed".

Rload is coupled between the vload node and switches 212 and 214 via a connection labeled "n3v5out" (negative 3.5-volt out). Closing of write switches 206 and 214, while read switches 208, 210 and 212 remain open, permits sufficient current to flow through the vload node to rupture the antifuse. Once programmed in this manner, the anti-fuse can be read by read circuit 106. In this arrangement, write switch 206 must have a voltage tolerance higher than that of the anti-fuse. To achieve this higher voltage tolerance, the switches, including write switch 206, are formed with thicker gate oxide layers (e.g., 50-70Å).

Read circuit 106 comprises an amplifier 220, threshold bias circuit 222 and an output sense transistor 224. The inverted input of amplifier 220 is coupled to switch 210 via a connection labeled "rdline". The non-inverted input of amplifier 220, which is labeled "Vref", is coupled to the threshold bias circuit 222. The output of amplifier 220 is coupled to the output sense transistor 224. With read switches 208, 210 and 212 closed, and write switches 214 and 206 open, the read circuit 106 compares the voltage at node vload to the reference voltage Vref. If the anti-fuse has been programmed, its resistance will be orders of magnitude lower than its un-programmed resistance. This difference in resistance is converted into a meaningful signal at the output of the read circuit labeled "Isense", as would become apparent to a person skilled in the relevant art based on the above description of the first embodiment.

[0033] FIG. 3 illustrates a deep N-well MOSFET used to implement the antifuse of the storage cell, according to an embodiment of the present invention. The deep N-well is shown at 302. Coupling of source 304 and drain 306 is shown at the n3v5out connection. The gate is coupled to vload. This low voltage CMOS anti-fuse transistor is programmed by controlled pulses of SKGF Ref: 1875.0220001

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electrical current with fixed amplitude to rupture its gate oxide. The electrical power through the gate oxide cannot exceed a certain voltage and duration as to avoid creating a void in the gate oxide. The advantage of the deep N-well is to isolate the memory cell and allow biasing of the well, source and drain to -3.5 volts when write switch 214 is closed. When write switch 206 is closed, 2.5 volts is applied to the gate through the vload, thus effectively creating a 6volt voltage difference across the gate oxide to rupture it. When the gate oxide is destroyed, a conductive path is formed between the gate electrode and the source/drain regions of the anti-fuse transistor. This resistance, under controlled electrical pulses, will be in the hundreds of ohms range or less, which is 4 orders of magnitude lower than the resistance prior to programming. To apply the high programming voltage across the gate oxide of the anti-fuse transistor, the drain and source regions of the anti-fuse transistor are connected to ground, and a programming voltage is applied to the gate of the anti-fuse transistor as described above.

transistor is used. The transistor's gate (shown as capacitor 402) is tied to a 1.2-volt sensing circuit 404 and a 5-volt tolerant switch 406. The 5-volt tolerant switch 406 is constructed from Input/Output MOS devices having a thicker gate oxide. An example 5-volt tolerant switch that can be used to implement this alternative embodiment of the present invention is described in "A High-Voltage Output Buffer Fabricated on a 2V CMOS Technology", by L.T. Clark, 1999 Symposium on VLSI Circuits Digest of Technical Papers (June 1999). These thicker gate oxide devices are connected to a resistor 408, whose other end is tied to the 5-volt supply. By appropriate switching, as would become apparent to a person skilled in the relevant art based on the above description of the first embodiment, the oxide is ruptured to program the anti-fuse.

[0035] FIGs. 5A and 5B are graphs showing data corresponding to the breakdown characteristics of the gate oxide, according to the present invention. Two configurations are shown. FIG. 5A shows breakdown characteristic with source and drain floating (i.e., not biased). FIG. 5B shows the same breakdown characteristic with the source and drain terminals tied to

the well. As more clearly indicated in FIG. 5B, the breakdown voltage of the gate oxide is about 4.6 volts.

FIGs. 6A and 6B show example data resulting from programming the anti-fuse transistors using about 5 volts and reading its resistance by applying 0.1 volts on the gate electrode with the grounded source/drain regions. The tight distribution of the programmed anti-fuse resistance makes the determination of its state quite easy. The 5-volt programming supply can be from the system power bus, which eliminates the need to integrate charge pump circuitry on the same chip. Data for gate dimensions of 10x10μm versus 50x2μm are illustrated. These geometries are provided by way of example and not limitation. Other geometries within the scope of the invention are contemplated by the inventors.

Finally, FIG. 7 illustrates a plot of the final (after programming) antifuse resistance versus applied power. The power is defined as Power = FuseV * I compliance * Time, as was applied by an HP4156b (Hewlett-Packard Company, Palo Alto, CA). The HP4156b is a precision semiconductor parameter analyzer used to vary three parameters for testing purposes: voltage, time duration and current compliance. HP4156b output voltage for the time duration specified and the clamp current (output to no more than the current compliance specified) when current starts to flow through the oxide layer is illustrated.

Conclusion

[0038] An advantage of the present invention is the compact nature of the non-volatile one-time programmable gate oxide capacitor manufactured using standard 0.13µm CMOS process, which exhibits direct gate tunneling current. Thus, integrating multitudes of anti-fuses on a single IC can be achieved according to the present invention.

[0039] One intended use is in the area of post package programming to install security codes. The codes cannot be electrically altered or decoded without destroying the circuitry. Alternatively, the anti-fuse capacitor/transistor can be used as memory elements in programmable logic devices and read only memory devices.

[0040] Reliability of the anti-fuse transistor and its final programmed state makes one hundred percent reliability possible.

[0041] Controlling the programmed state resistance of a one-time programming element is also possible according to the present invention. A four-order of magnitude difference in resistance is yielded before and after programming. This makes the circuitry design easier and more compact because the low programmed resistance, tighter resistance spread, and little or no resistance variation with time.

[0042] Programming voltage is low and usually available directly from system bus. Thus, the present invention eliminates charge pump circuitry on chip.

[0043] The present invention may be implemented with various changes and substitutions to the illustrated embodiments. For example, the present invention may be implemented on substrates comprised of materials other than silicon, such as, for example, gallium arsenide or sapphire.

[0044] It will be readily understood by those skilled in the art and having the benefit of this disclosure, that various other changes in the details, materials, and arrangements of the materials and steps which have been described and illustrated in order to explain the nature of this invention may be made without departing from the principles and scope of the invention as expressed in the subjoined claims.